



**ELECTRONIC COPY**

LG641490619  
Report verification at igi.org



July 16, 2024  
IGI Report Number **LG641490619**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **8.80 X 6.12 X 4.09 MM**  
**GRADING RESULTS**  
Carat Weight **2.15 CARATS**  
Color Grade **G**  
Clarity Grade **VS 1**

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**GRADING RESULTS**

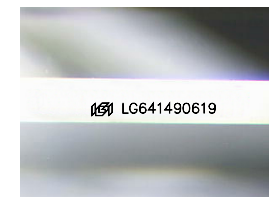
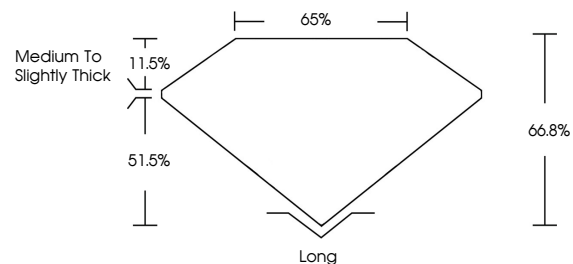
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Color Grade **G**  
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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **LG641490619**

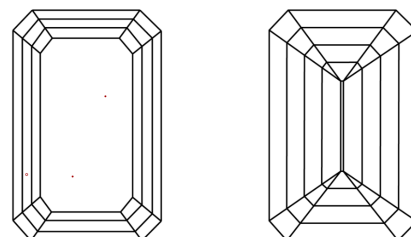
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

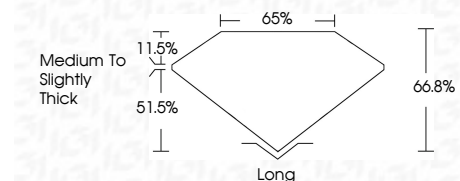
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**

July 16, 2024  
IGI Report No **LG641490619**  
**EMERALD CUT**  
Carat Weight **2.15 CARATS**  
Color Grade **G**  
Clarity Grade **VS 1**  
Depth **66.8%**  
Table **65%**  
Girdle **Medium to Slightly Thick**  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **LG641490619**

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